PTO/SB/21 (08-03)

Approved for use through 08/30/2003. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE he Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. **Application Number** 10/617.321 Filing Date **TRANSMITTAL** July 10, 2003 **FORM** First Named Inventor Byung-Jin Choi et al. Art Unit 2834 (to be used for all correspondence after initial filing) **Examiner Name** Unassigned Attorney Docket Number PA88/UTS-39-05d09 Total Number of Pages in This Submission **ENCLOSURES** (Check all that apply) After Allowance communication ~ Fee Transmittal Form Drawing(s) to Technology Center (TC) Appeal Communication to Board Licensing-related Papers Fee Attached of Appeals and Interferences Appeal Communication to TC Petition Amendment/Reply (Appeal Notice, Brief, Reply Brief) Petition to Convert to a Proprietary Information After Final Provisional Application Power of Attorney, Revocation Status Letter Affidavits/declaration(s) Change of Correspondence Address Other Enclosure(s) (please Terminal Disclaimer Extension of Time Request Identify below): Form 1449 - IDS Request for Refund **Express Abandonment Request** Three (3) References Return Receipt Postcard to Kenneth Brooks CD, Number of CD(s) Information Disclosure Statement Remarks Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53 SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Firm Law Office of Kenneth C. Brooks Individual name Signature Date CERTIFICATE OF TRANSMISSION/MAILING I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below. Typed or printed name Alexis Sheffield Date teb. 18,2004 Signature

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Choi et al.

Serial No.: 10/617,321

Filing Date: July 10, 2003

PATENT APPLICATION

Group Art Unit: 2834

Examiner: Unassigned

For: A METHOD OF SEPARATING A TEMPLATE FROM A SUBSTRATE DURING

IMPRINT LITHOGRAPHY.

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Alexandria, VA 22313-1450

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure under 37 C.F.R. § 1.56. Form PTO-1449 and a copy of each reference recited below accompanies this document. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

ISSUED PATENTS

Patent Number	Inventor	<u> Grant Date</u>	
4,326,805	Feldman et al.	Apr. 27, 1982	
4,724,222	Feldman et al.	Feb. 9, 1988	

NON-PATENT DOCUMENTS

Feldman et al., "Wafer Chuck for Magnification correction in X-ray Lithography," *Journal of Vacuum Science and Technology*, vol. B 16(6), pp. 3476-3479, Nov/Dec 1998.

CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop PATENT APPLICATION, Alexandria, VA 22313-1450

Signed: ally Sheffield

Typed Name: Alexis Sheffield

Feb. 18, 2004

Respectfully Submitted,

Kenneth C. Brooks Reg. No. 38,393

P.O. Box 81536

Austin, Texas 78708-1536 Telephone: 512-527-0104 Facsimile: 512-527-0107 patentsrus@earthlink.net TRADE!

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known		
Application Number	10/617,321	
Filing Date	07/10/2003	
First Named Inventor	Choi et al.	
Group Art Unit	2834	
Examiner Name	Unassigned	
Attorney Docket Number	PA88/UTS-39-05D09	

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	U.S. Patent D	Nocument Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	A1	4,326,805		Feldman et al.	04-27-1982	
	A2	4,724,222		Feldman et al.	102-09-1988	
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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Attorney Docket Number	PA88/UTS-39-05D09		

OTHER PRIOF	R ART -	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite, No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Feldman et al., "Wafer Chuck for Magnification correction in X-ray Lithography," Journal of Vacuum Science	
:	А3	and Technology, Nov/Dec 1998, pp. 3476-3479, vol. B 16(6).	
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